

PATENT NUMBER and
ISSUE DATE

U.S. UTILITY Patent Application

APPL NUM 10063887	FILING DATE 05/21/2002	CLASS 257 033	SUBCLASS 620	GAU 2832 2839	EXAMINER PRENTY
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**APPLICANTS: Fu Chien-Chih;

**CONTINUING DATA VERIFIED:

None

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** FOREIGN APPLICATIONS VERIFIED:

TAIWAN 091101405 01/28/2002

PG-PUB DO NOT PUBLISH ☐

RESCIND ☐

Foreign priority claimed ☒ yes ☐ no
35 USC 119 conditions met ☒ yes ☐ no

ATTORNEY DOCKET NO

Verified and Acknowledged Examiners's initials MP

AMIP0015USA

TITLE : Scribe lines for increasing wafer utilizable area

U.S. DEPT. OF COMM./PAT & TM-PTO-436L (Rev. 12-94)

NOTICE OF ALLOWANCE MAILED

Assistant Examiner

CLAIMS ALLOWED

Total Claims

Print Claim for
O.G.

ISSUE FEE

Amount Due

Date Paid

DRAWING

Sheet Drwg.

Figs. Drwg.

Print Fig.

Primary Examiner

PREPARED FOR ISSUE

Application Examiner

☐ TERMINAL
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